

Docket No.: GR 98 P 4137 P



I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231.

By: 

Date: March 13, 2001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hans-Jürgen Hacke et al.
Appl. No. : 09/761,594
Filed : January 16, 2001
Title : Semiconductor Device in Chip Format and Method for
Producing It

CLAIM FOR PRIORITY

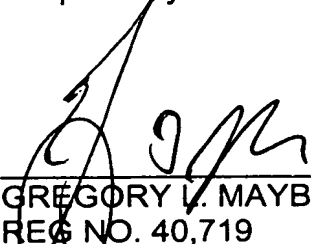
Hon. Commissioner of Patents and Trademarks,
Washington, D.C. 20231

Sir:

Claim is hereby made for a right of priority under Title 35, U.S. Code, Section 119, based upon the German Patent Application 198 32 706.4 filed July 14, 1998.

A certified copy of the above-mentioned foreign patent application is being submitted herewith.

Respectfully submitted,



GREGORY L. MAYBACK
REG NO. 40,719

Date: March 13, 2001

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/mjb



BUNDESREPUBLIK DEUTSCHLAND



Prioritätsbescheinigung über die Einreichung einer Patentanmeldung

Aktenzeichen: 198 32 706.4

Anmeldetag: 14. Juli 1998

Anmelder/Inhaber: Siemens AG, München/DE

Bezeichnung: Halbleiterbauelement im Chip-Format
und Verfahren zu seiner Herstellung

IPC: H 01 L 23/538

Die angehefteten Stücke sind eine richtige und genaue Wiedergabe der
ursprünglichen Unterlagen dieser Patentanmeldung.

München, den 13. Februar 2001
Deutsches Patent- und Markenamt
Der Präsident
Im Auftrag



JFW

Docket No.: GR 98 P 4137 D

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

By: _____ Date: October 19, 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/937,418 Confirmation No: 9046
Applicant : Hans-Jürgen Hacke, et al.
Filed : September 9, 2004
Art Unit : 3762
Examiner : Terri L. Smith
Title : Method for Producing a Semiconductor Device in a
Chip Format
Docket No. : GR 98 P 4137 D
Customer No. : 24131
Date of Notice of Allowance : July 19, 2005

LETTER

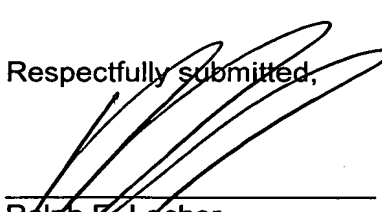
Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450

Sir:

Please note that the German Priority document number 198 32 706.4 dated July 14, 1998 was filed on March 15, 2001 in the U.S Patent Office. Please find enclosed copies of the following:

- 1) Claim for Priority
- 2) The cover page of priority document; and
- 3) The return postcard indicating receipt by the PTO.

Respectfully submitted,



Ralph E. Locher
Reg. No. 41,947

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DOCKET NO. GR. 98P 4137 P... Mailed March 13, 2001

APPLIC. NO. 09/761,594 Express Mail

The stamp of the Patent Office hereon may be considered the date on which papers indicated below were received.

Applic pgs. Rule 53b New ☐ Contin ☐ Div ☐ CIP ☐ / Rule 53c Prov. ☐ / Rule 53d CPA ☐
☐ CIP ... pgs ☐ TM ☐ Design ☐ ... Dwgs ☐ inf. ☐ fm ☒ Missing Certif.
☒ Priority Claim ☒ Cert. Prior. Doc(s) ☐ PCT Cover Sheet WO.
☐ Amend pgs. ... ☐ Prel. Amend pgs. ... ☒ Letter
☐ Response pgs. ... ☐ 37CFR1.116 ☐ Not. of Appeal
☐ Brief pgs. ... ☐ Appndx pgs. ... ☐ I.D.S. + ... Refs.
☒ Assoc Pwr of Atty ☐ ... Specimen ☒ Declaration
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